

PATENT  
2114-0117PUS1

IN THE U. S. PATENT AND TRADEMARK OFFICE

Applicant: Takanori ICHIKI Conf: 5623  
Serial No.: 11/590,969 Art Unit: 1759  
Filed: January 5, 2007 Examiner: TAI, Xiuyu  
For: MICRO PLASMA JET GENERATOR

**REPLY UNDER 37 C.F.R.1.114**

**MS RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Due May 3, 2011**

Sir:

In response to the Office Action mailed February 03, 2011, and the Advisory Action dated April 20, 2011, the following remarks are respectfully submitted in connection with the above-identified application:

This Paper includes

**Amendments to the Claims,**

**Remarks, and**

**Copy of "Review of Inductively Coupled Plasmas for Plasma Processing."**

**A Request for Continued Examination (RCE) is being filed concurrently.**